Electronic Acknowledgement Receipt				
EFS ID:	9680016			
Application Number:	10573406			
International Application Number:				
Confirmation Number:	2973			
Title of Invention:	Sputtering Target and Process For Producing Si Oxide Film Therewith			
First Named Inventor/Applicant Name:	Koichi Watanabe			
Customer Number:	22428			
Filer:	Pavan K. Agarwal/Renell Feimster			
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1		IDS.pdf	233158	ves	4
'	123.pui	3ad7ec0d3cecd8cb46ee4b5ee192f8681d7 85e6f	′		

	Multipart Description/PDF files in .zip description						
	Document Description Transmittal Letter Information Disclosure Statement (IDS) Filed (SB/08)		Start	End 3			
			1				
			4				
Warnings:							
Information:		_					
2	2 NPL Documents	JPOfficeAction.pdf	330219	no	8		
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Warnings:							
Information:							
3	3 Foreign Reference	PofA2 ndf	1895487	no	27		
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Warnings:							
Information:							
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4 Foreign Reference	RefA3.pdf	cf246630b8cd5192560a0de5024efdcdd87 c1989	no	4			
Warnings:							
Information:							
5	5 Foreign Reference	RefA4.pdf	654330	no	10		
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Information:							
6 Foreign Reference	RefA5.pdf	271776	no	7			
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Warnings:							
Information:							
7 Foreign Reference	RefA6.pdf	611780	no	11			
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.